

INFORMATION DISCLOSURE CITATION*(Use several sheets if necessary)*

Docket Number (Optional)

SETI-0004

Application Number

Applicant(s)

Gaska et al.

Filing Date

Group Art Unit

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

		"Insulating Gate III-N Heterostructure Field-Effect Transistors for High-Power Microwave and Switching Applications," M. A. Khan et al., IEEE Transactions on Microwave Theory and Techniques, Vol. 51, No. 2, February 2003, pp. 624-633.
		"Surface Acoustic Wave Propagation Characteristics of Aluminum Nitride Thin Films Grown on Polycrystalline Diamond," G. F. Iriarte, Journal of Applied Physics, Vol. 93, No. 12, June 15, 2003, pp. 9604-9609.

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"Temperature Effect on the Quality of AlN Thin Films," M. P. Thompson et al., MRS Internet J. Nitride Semicond. Res. 4S1, G3.7 (1999).

"High Rate and Selective Etching of GaN, AlaN, and AlN Using an Inductively Coupled Plasma," S. A. Smith et al., Applied Physics Letters, Vol. 71, No. 25, December 22, 1997, pp. 3631-3633.

"Reactive Sputter Deposition of Highly Oriented AlN Films at Room Temperature," G.F. Iriarte et al., J. Mater. Res., Vol. 17, No. 6, June 2002, pp. 1469-1475.

"PVT Growth of Bulk AlN Crystals With Low Oxygen Contamination," M. Bickermann et al., Phys. Stat. Sol. (a), Vol. 195, No. 1, 3-10 (2003), pp. 1 - 4.

"Introduction to Solid-State Lighting," Zukauskas et al., pp. 61-69. (2002).

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